

## THE UNITED STATES PATENT AND TRADEMARK OFFICE

## In re Application of:

Zahorik et al.

Serial No.: 10/647,634

**Filed:** August 25, 2003

For: METHODS FOR SELECTIVE REMOVAL OF MATERIAL FROM WAFER ALIGNMENT MARKS

Confirmation No.: 3991

Examiner: L. Vinh

Group Art Unit: 1765

Attorney Docket No.: 2269-3131.6US

(96-1119.06/US)

## CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

July 26, 2005

Date

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## **AMENDMENT**

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This amendment is in response to the Office Action of April 27, 2005 whose initial period of response is set to expire on July 27, 2005.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.